

Notice of References Cited

Application/Control No.

10/719,002

Applicant(s)/Patent Under
Reexamination
SPIVACK ET AL.

Examiner

Thanh-Ha Dang

Art Unit

2163

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0147748 A1	10-2002	Huang et al.	707/517
*	B	US-2002/0194154 A1	12-2002	Levy et al.	707/1
*	C	US-2002/0194201 A1	12-2002	Wilbanks et al.	707/104.1
*	D	US-2003/0120730 A1	06-2003	Kuno et al.	709/204
*	E	US-2003/0126136 A1	07-2003	Omoigui, Nosa	707/10
*	F	US-2003/0149934 A1	08-2003	Worden, Robert Peel	715/513
*	G	US-6,711,585 B1	03-2004	Copperman et al.	707/104.1
*	H	US-6,847,974 B2	01-2005	Wachtel, David C.	707/101
*	I	US-7,072,883 B2	07-2006	Potok et al.	707/3
*	J	US-7,093,200 B2	08-2006	Schreiber et al.	715/835
*	K	US-7,284,196 B2	10-2007	Skeen et al.	715/234
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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